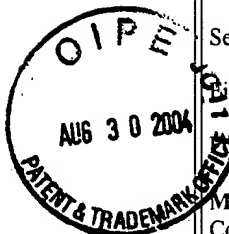


IPW AF
2823



In re application of: Jammy et al.
Serial No.: 09/363,523 Group: Art Unit 2823
Filed: July 29, 1999 Examiner: Estrada, Michelle
Title: METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria VA 22313-1450

Corres. and Mail
BOX AF

AMENDMENT TRANSMITTAL FORM

Sir:

Transmitted herewith is an amendment in the above-identified application.

- [] Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.
[] A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.
[X] No additional fee is required.

The fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	(Col. 3)	SMALL ENTITY	OTHER THAN SMALL ENTITY
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE
TOTAL	7 * MINUS	23**	= 0 X	9	\$ 0
INDEP.	1* MINUS	3***	= 0 X	43	\$ 0
[] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM			X	145	\$ 290
				TOTAL	OR TOTAL \$ 0

*If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

** If the "Highest No. Previously Paid for" IN THIS SPACE is less than 20, enter "20".

*** If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

- [] Please charge Deposit Account No. ____ in the amount of \$____. Two (2) copies of this sheet are enclosed.
[] Please charge fee of \$____ for _____ by Credit Card Payment Form PTO-2038 enclosed herewith
[X] Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. 50-0679. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. 50-0679 therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

F. CHAU & ASSOCIATES, LLC
130 Woodbury Road
Woodbury, New York 11797
Tel: (516) 692-8888
Fax: (516) 692-8889

Respectfully submitted,

Thomas W. McNally
Reg. No. 48,609
Attorney for Applicant

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria VA 22313-1450 on August 27, 2004.

Dated: 27 August 2004

Thomas W. McNally



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RESPONSE UNDER 37 C.F.R. § 1.116
-EXPEDITED PROCEDURE-
EXAMINING GROUP ART GROUP UNIT 1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jammy et al.

Examiner: Estrada, Michelle

Serial No: 09/363,523

Group Art Unit: 2823

Filed: July 29, 1999

Docket: 99-P-7722-US (8055-98)

For: **METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

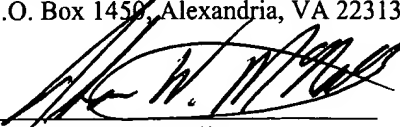
RESPONSE

This is a response to a Final Office Action mailed on June 28, 2004. Please consider the following remarks to the above-identified application:

CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop: Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 27, 2004.

Dated: 27 August 2004


Thomas W. McNally